



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Akram et. al.

Serial No.: 10/620,003

Filed: July 14, 2003

For: METHODS OF FABRICATING SILICIDE PATTERN STRUCTURES

Confirmation No.: 7478

Examiner: K. Nguyen

Group Art Unit: 2823

Attorney Docket No.: 2269-3521.5US

97-0985.05/US

## CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 13, 2004 Signature

Signature

Rachael M. Harris
Name (Type/Print)

## AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Final Office Action mailed on August 10, 2004, the three-month shortened statutory period for response to which expires on November 10, 2004. This Amendment is being submitted within two months of the mailing date of the Final Office Action.

Amendments to the claims are set forth in the listing of the claims, which begins on page 2 of this paper; and

Remarks start at page 7 of this paper.

Slease Enter k.n. 09/29/04